

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of
Ravi Iyer

Parent Application Serial No. 08/599,675
Parent Application Filed: February 12, 1996

Serial No.: Unknown

Filed: Herewith

For: PLANARIZATION USING PLASMA
OXIDIZED AMORPHOUS SILICON

Assistant Commissioner
for Patents
Washington, D.C. 20231

Sir:

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.97(b)(1) AND 1.98**

In compliance with the duty of disclosure under 37 C.F.R. § 1.56(a), Applicants respectfully request that this Information Disclosure Statement be entered and that the listed references be considered by the Examiner and made of record. Copies of the listed references are enclosed for the convenience of the Examiner.

In accordance with 37 C.F.R. § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made, as an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b), or as a representation that no other possibly material information, as defined in 37 C.F.R. § 1.56(b), exists.

The following information is listed below in accordance with 37 C.F.R. § 1.98. Any explanation of non-English language documents contained in this Information Disclosure Statement is believed to constitute a concise explanation of the relevance of the listed reference as it is presently understood by the individual designated in § 1.56(c) most knowledgeable about the content of the listed reference, in accordance with 37 C.F.R. § 1.98(a)(3).

Group Art Unit: 1104

Examiner: Whipple, M.

Atty. Dkt: MICS:0015--2/FLE
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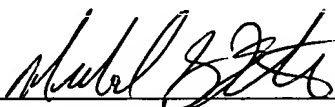
Country or Issuing Patent Office	Document Number	Publication Date
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Author	Title	Relevant Pages	Date	Place of Publication
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Respectfully submitted,

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